Docket No.: 1028-0199PUS1 (PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Robert STEVENS et al.

Application No.: 10/530,524 Confirmation No.: 6766

Filed: April 7, 2005 Art Unit: 2874

For: FIBRE OPTIC BASED SEMICONDUCTOR Examiner: C. H. Chu
MICRO SENSORS FOR SENSING PRESSURE

MICKO SENSORS FOR SENSING PRESSOR
OR TEMPERATURE, FABRICATION
METHODS OF SAID SENSORS, AND A
METHOD OF SECURING AN OPTICAL
FIBRE TO A SILICON BLOCK

## REPLY TO RESTRICTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir

In reply to the Restriction Requirement dated October 6, 2006, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.